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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/043,709	01/09/2002	Kuo-Yu Chou	67,200-603	6454	
7:	590 08/13/2003				
TUNG & ASSOCIATES Suite 120 838 W. Long Lake Road			EXAMINER		
			LE, THAO X		
Bloomfield Hil	ls, MI 48302		ART UNIT PAPER NUMBEI		
			2814	2814	
•			DATE MAILED: 08/13/2003		

Please find below and/or attached an Office communication concerning this application or proceeding.

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		Application No.	Applicant(s)	•			
Office Action Summary		10/043,709	CHOU ET AL.				
		Examiner	Art Unit				
		Thao X Le	2814				
Period fo	The MAILING DATE of this communication app or Reply	ears on the cov r sheet with t	the corr spond nc addre	<del>!</del> SS			
THE I - Exter after - If the - If NC - Failu - Any r	ORTENED STATUTORY PERIOD FOR REPLY MAILING DATE OF THIS COMMUNICATION. In maions of time may be available under the provisions of 37 CFR 1.13 SIX (6) MONTHS from the mailing date of this communication. It period for reply specified above is less than thirty (30) days, a reply operiod for reply is specified above, the maximum statutory period were to reply within the set or extended period for reply will, by statute, reply received by the Office later than three months after the mailing and patent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may a reply within the statutory minimum of thirty (3 rill apply and will expire SIX (6) MONTHS cause the application to become ABANI	be timely filed  O) days will be considered timely.  If from the mailing date of this common the mailing date of this common the mailing date.	nunication.			
1)⊠	Responsive to communication(s) filed on <u>05 A</u>	<u>1ay 2003</u> .					
2a) <u></u> □	This action is <b>FINAL</b> . 2b)⊠ Th	s action is non-final.					
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.							
·	ion of Claims						
•	Claim(s) 13-24 and 29-39 is/are pending in the application.						
	4a) Of the above claim(s) <u>13-24</u> is/are withdrawn from consideration.						
	Claim(s) is/are allowed.						
	☑ Claim(s) <u>29-39</u> is/are rejected.						
	Claim(s) is/are objected to.						
•	Claim(s) are subject to restriction and/or	r election requirement.					
	ion Papers	_					
9) The specification is objected to by the Examiner.							
10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.							
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).							
11) The proposed drawing correction filed on is: a) approved b) disapproved by the Examiner.							
If approved, corrected drawings are required in reply to this Office action.  12) The oath or declaration is objected to by the Examiner.							
,	•	allinici.					
	under 35 U.S.C. §§ 119 and 120		40(-) (-1) (6)				
13) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).							
a) All b) Some * c) None of:							
	1. Certified copies of the priority documents have been received.						
	2. Certified copies of the priority documents have been received in Application No						
* 5	3. Copies of the certified copies of the prior application from the International Bu See the attached detailed Office action for a list	reau (PCT Rule 17.2(a)).		age			
14) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).							
	) ☐ The translation of the foreign language pro Acknowledgment is made of a claim for domesti	• •					
Attachmen	-						
2) Notic	ce of References Cited (PTO-892) ce of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO-1449) Paper No(s)	5) Notice of Info	nmary (PTO-413) Paper No(s). rmal Patent Application (PTO-1				

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#### DETAILED ACTION

### Acknowledgement

1. Applicant's cancellation of claims 1-12 and 25-28 in Paper No. 8 is acknowledged.

## Claim Rejections - 35 USC § 103

- 2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which-said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).
- 4. Claims 29-39 are rejected under 35 U.S.C. 103(a) as being unpatentable over US 6,016,000 to Moslehi in view of US 6,417,088 to Ho et al.

Regarding claim 29, Moslehi discloses a method for forming a wiring bond pad utilized in wire bonding operation on an integrated circuit (IC) device comprising the steps of: providing a substrate, fig. 15, thereafter configuring substrate to comprise a wiring bond pad to comprises a



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single metal layer, step 144 fig. 6B, wherein single metal layer does not share single metal layer with any other material, thereafter positioning at least one IC device below wiring bond pad to thereby conserve IC space and improve wiring bond pad efficiency as a result of configuring wiring bond pad to comprise a single metal layer, column 1 line 10-25, thereafter locating single metal layer above a plurality of intermetal dielectric (IMD) layer, step 122 fig. 6B, and thereafter locating at least one IC device below plurality of IMD layer, fig. 15, wherein single metal layer comprises a metal-8 layer.

But, Moslehi does not expressly disclose locating a buffer and bonding layer immediately above single metal layer.

However, Ho reference discloses the method for forming a wiring bond pad 30, column 3 line 10, comprises a aluminum buffer layer 52, fig. 6, column 4 line 1, and bonding layer 60, column 4 line 53, immediately above single metal layer 30. At the time the invention was made; it would have been obvious to one of ordinary skill in the art to combine the buffer layer and bonding layer teaching of Ho with Moslehi, because it would have increased the adhesion between the bond pad and bonding layer as taught by Ho, column 4 line 30-32.

Regarding claims 30-31, Moslehi discloses the method wherein the plurality of IMD layers comprises at least IDM-1 to IDM-7 layers, fig. 15 and step 132 fig. 6B, wherein the metal-8 layers comprises a copper layer, step 130 fig. 6B.

Regarding claims 32, 38-39 Moslehi discloses a method for forming a wiring bond pad utilized in wire bonding operation on an integrated circuit (IC) device comprising the steps of: providing a substrate, fig. 15, thereafter configuring substrate to comprise a wiring bond pad to

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comprises a single metal layer, step 144 fig. 6B, wherein single metal layer does not share single metal layer with any other material, thereafter locating at least one IC device below wiring bond pad to thereby conserve IC space and improve wiring bond pad efficiency as a result of configuring wiring bond pad to comprise a single metal layer, column 1 line 10-25, thereafter locating a single metal layer above a plurality of IML layers, wherein plurality of IMD layers comprises at least IMD-1 to IMD-7 layers, fig. 15 and step 132 fig. 6B, and thereafter locating at least one IC device below plurality of IMD layer, fig. 15, wherein single metal layer comprises a metal-8 of copper, step 130 fig. 6B.

But, Moslehi does not expressly disclose locating a buffer and bonding layer immediately above single metal layer comprises a layer having a thickness in a range of and including 10KA°-20KA°.

However, Ho reference discloses the method for forming a wiring bond pad 30, column 3 line 10, comprises a aluminum buffer layer 52, fig. 6, column 4 line 1, and bonding layer 60, column 4 line 53, immediately above single metal layer 30. At the time the invention was made; it would have been obvious to one of ordinary skill in the art to combine the buffer layer and bonding layer teaching of Ho with Moslehi, because it would have increased the adhesion between the bond pad and bonding layer as taught by Ho, column 4 line 30-32.

With respect to the thickness, Ho reference discloses the method for forming a wiring bond pad, fig. 6 comprises a aluminum buffer layer 52, column 3 line 3, and bonding layer 60, column 4 line 53, immediately above metal layer 30, wherein the aluminum buffer layer having the thickness in a range of 5000 A°, column 4 line 35.

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Accordingly, it would have been obvious to one of ordinary skill in art to use buffer layer 52 teaching of Ho in the range as claimed, because it has been held that where the general conditions of the claims are discloses in the prior art, it is not inventive to discover the optimum or workable range by routine experimentation. See In re Aller, 220 F.2d 454, 105 USPQ 233, 235 (CCPA 1955).

Regarding claims 33-37, Moslehi does not disclose the single metal layer comprises copper layer having a thickness of approximately 10-18KA°.

However, Moslehi discloses the copper single metal can be formed with thinner thickness, column 2 lines 7-15 and line 31. Accordingly, it would have been obvious to one of ordinary skill in art to use teaching of Moslehi in the range as claimed, because it has been held that where the general conditions of the claims are discloses in the prior art, it is not inventive to discover the optimum or workable range by routine experimentation. See In re Aller, 220 F.2d 454, 105 USPQ 233, 235 (CCPA 1955).

#### Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Thao X Le whose telephone number is 703-306-0208. The examiner can normally be reached on M-F from 8:00 AM - 4:30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Wael M Fahmy can be reached on 703-308-4918. The fax phone numbers for the organization where this application or proceeding is assigned are 703-308-7722 for regular communications and 703-308-7722 for After Final communications.

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Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-308-0956.

Thao X. Le August 5, 2003

> LONG PHAMI PRIMARY EXAMINER